503712842 02/27/2016

PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
YU ZHAO	02/26/2016
ZHANDONG ZHANG	02/26/2016

RECEIVING PARTY DATA

Name:	WUHAN CHINA STAR OPTOELECTRONICS TECHNOLOGY CO., LTD	
Street Address:	BUILDING C5 NO. 666 GAOXIN AVENUE,	
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City:	WUHAN, HUBEI,	
State/Country:	CHINA	
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PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	14915225

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ATTORNEY DOCKET NUMBER: CM16012

NAME OF SUBMITTER: ANDREW C. CHENG

SIGNATURE: /Andrew C. Cheng, Reg. No. 60891/

DATE SIGNED: 02/27/2016

Total Attachments: 2

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PATENT 503712842 REEL: 037846 FRAME: 0465

Attorney Docket No.: CM16012

ASSIGNMENT

In consideration of value received, the receipt and sufficiency of which are hereby acknowledged, the undersigned ASSIGNOR(S)

1st Name:	ZHAO, Yu				
Residing at	Building C5, Biolake of Optics Valley, No.666 Gaoxin Avenue, East Lake High-				
	tech Development Zone, Wuhan, Hubei, 430070, China.				
2nd Name:	ZHANG, Zhandong				
Residing at	Building C5, Biolake of Optics Valley, No.666 Gaoxin Avenue, East Lake High-				
	tech Development Zone, Wuhan,Hubei,430070,China.				
hereby Under	an Obligation to sell, assign and transfer unto:				
WUHAN CHI	NA STAR OPTOELECTRONICS TECHNOLOGY CO., LTD. of				
<u>WUHAN , HU</u>	BEI , CHINA (hereinafter referred as "ASSIGNEE"), its successors and assigns,				
the entire righ	t, title and interest in and to the invention known as SEMICONDUCTOR LAYER				
STRUCTURE	AND METHOD FOR FABRICATING THE SAME (hereinafter referred as				
"INVENTION"), for which a United States Patent Application was executed concurrently				
herewith or, if	not so executed, was:				
	ed on;				
	, Application Serial No; or				
c. [X] establist	ned by PCT International Patent Application No. PCT/CN2016/071710 .				
an application	for Letters Patent of United States of America.				
The undersign	ned agree(s) to execute all papers necessary in connection with this application for				
patent in the U	JSPTO for the invention, and any continuation, divisional or reissue applications				

The undersigned agree(s) to execute all papers necessary in connection with any post-grant proceeding which may occur in connection with this application or continuation, divisional or reissue thereof and to cooperate with the Assignee in every way possible in obtaining evidence and going forward with such post-grant proceeding.

thereof and also to execute separate assignments in connection with such applications as the

Assignee may deem necessary or expedient.

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The undersigned agree(s) to execute all papers and documents and perform any act which may be necessary in connection with claims or provisions of the International Convention for Protection of Industrial Property or similar agreements.

The undersigned agree(s) to perform all affirmative acts which may be necessary to obtain a grant of a valid United States patent to the Assignee.

AND the undersigned hereby authorize(s) and request(s) the United States Commissioner of Patents and Trademarks to issue said Letters Patent to the said ASSIGNEE, for its interest as ASSIGNEE, its successors, assigns and legal representatives; the undersigned agree(s) that the attorneys of record in said application, if any, shall hereafter act on behalf of said ASSIGNEE;

AND the undersigned hereby agree(s) to testify and execute any papers for ASSIGNEE, its successors, assigns and legal representatives, deemed essential by ASSIGNEE to ASSIGNEE's full protection and title in and to the invention hereby transferred.

Signature of 1st Inventor	zHAO, Yu	Executed Date	2016/2/26
Diamatuus af			
Signature of 2nd Inventor	24ANG, Zhandong	Executed Date	20/6/2/26

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